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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Filing DateAugust 1, 2001
InventorShane J. Trapp
AssigneeMicron Technology, Inc.
Group Art Unit2813
ExaminerDavid S. Blum
Attorney Docket No.MI22-1674
Title: Method of Forming Integrated Circuitry and Method of Forming Shallow
Trench Isolation in a Semiconductor Substrate

Shane J. Trapp
8/18/03

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

7/23/03

By:

Mark S. Matkin
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